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(476) (((gate and protect\$3) and gate.clm.) and

(432) (((gate and protect\$3) and gate.clm.) and

(257) (((gate and protect\$3) and gate.clm.) and

(13) (((gate and protect\$3) and gate.clm.) and

(9821) gate.clm. and implant\$3.clm.

(6573) (gate.clm. and implant\$3.clm.) and ((

(5525) (gate.clm. and implant\$3.clm.) and ((

(5016) (gate.clm. and implant\$3.clm.) and ((

(958) ((gate.clm. and implant\$3.clm.) and ((

(680) (((gate.clm. and implant\$3.clm.) and ((

(531) (((gate.clm. and implant\$3.clm.) and ((

(395) (((gate.clm. and implant\$3.clm.) and ((

(58) (((gate.clm. and implant\$3.clm.) and ((

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(((PVD.clm. or TPVD.clm. or (physical adj vapor adj deposition).clm.) and (conductance.clm. or heater.clm. or heating.clm. or container.clm.)) and heat\$3.clm.) and (pressure or vapor\$3).clm.) and gas\$5.clm.) and conductan\$3

Abstract

Abstract

Drawings

References

	U	I	P	T	P	Document ID	Issue Date	Pages	Title	Current OB	Current OR	Retrieval	Inventor					
1						US 20030183306	20031002	239	Selected processing for non-equilibrium light a	148/404	148/420		Hehmann, Franz et al.					
2						US 2003030313	20030313	16	Synthesis of YBa2Cu3O7	505/100	148/437		Wiesmann, Harold et al.					
3						US 20030050195	20030213	17	An Apparatus For Annealing Substrates In	204/192.2			Yu, Sang-Ho et al.					
4						US 20030029715	20021121	14	Method for forming interconnects on semico	257/758	257/E21.58		Andricacos, Panavotis Constant					
5						US 20020171151	20020808	14	METHOD FOR FORMING INTERCONNECTS ON SEMICO	257/758	257/E21.58		Andricacos, Panavotis Constant					
6						US 20020105082	20020321	17	Fabrication and structure of electron e	313/495	313/309		Xu, Xueping et al.					
7						US 20020033663	20020214	12	High temperature metal deposition for reducing	438/581	257/E21.16		Saigal, Dinesh et al.					
8						US 20020019119	20011115	17	ELECTRON EMITTERS COATED WITH CARBON CONT	313/497	313/309		KU, KUEPING et al.					
9						US 20010040431	20010405	17	Fabrication of electron emitters coated with ma	445/50	445/51		Xu, Xueping et al.					
10						US 20010000163	20040921	17	Synthesis of YBa2Cu3O7 using sub-atmospheric b	505/470	427/350		Wiesmann, Harold et al.					
11						B2 6579783	20030617	12	Method for high temperature metal depos	438/581	257/E21.16		Saigal, Dinesh et al.					
12						B2 6429523	20020806	13	Method for forming interconnects on semico	257/758	257/751		Andricacos, Panavotis Constant					
13						B1 6380075	20020430	9	Method for forming an open-bottom liner for a	438/637	438/627		Cabral, Jr., Cyril et al.					
14						B2 6379210	20020430	19	Fabrication of electron emitters coated with ma	445/50	445/24		Xu, Xueping et al.					
15						RE36517	20000118	22	Thin film magnet, cylindrical ferromagnet	427/132	427/128		Araki, Takeshi et al.					
16						E 5676998	19971014	21	Thin film magnet, cylindrical ferromagnet	427/132	427/129		Araki, Takeshi et al.					
17						A				427/132	427/128		Araki, Takeshi et al.					

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